



Attorney Docket No.: 101246.52582US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399  
First Named Inventor : Yoshihiro KATO  
Filed : July 22, 2003  
TC/A.U. : 1763  
Examiner : J.R. Lund

Docket No. : 101246.52582US  
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

**VERIFICATION OF TRANSLATION**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

I, Takanori Menjo, hereby declare as follows:

1. I am a citizen of Japan residing at  
c/o Ashida & Kimura of 2-7, Kandanishiki-cho, Chiyoda-ku, Tokyo Japan
2. I am familiar with the Japanese and English languages.
3. I have reviewed the attached English translation of international application no. PCT/JP02/00429 and compared it with the Japanese language original, and to the best of my knowledge and belief the attached English translation is a true and correct translation of the Japanese text.
4. All statements made herein of my own knowledge are true, and all statements made on information and belief are believed to be true, and further, these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under §1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the above-captioned patent application or any patent issued thereon.

Takanori Menjo  
Signature

Takanori Menjo  
Printed Name

Date: April 23, 2007